



IFN
PATENT,

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yasuhiko ONISHI et al

Serial No.: 10/735,501

Group Art Unit:2811

Filed: December 12, 2003

Examiner:

For: SUPER-JUNCTION SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

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Marc A. Rossi

STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It would be appreciated if you would indicate the status of the above-identified
application below, including an indication as to when the next communication can be expected,
and return this sheet to the undersigned.

Respectfully submitted,

Date: 12/10/09

[Signature]
Marc A. Rossi
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Attorney Docket No. FUJI:180A

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